



EXPEDITED PROCEDURE
Examining Group Number 2800

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amendment

D.C.

6/1/04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: David C. Chu

Examiner: Demetrius R. Pretlow

Serial No.: 10/052,673

Group Art Unit: 2863

Filed: January 17, 2002

Docket No.: 10020043-1 (A310.119.101)

Due Date: May 31, 2004

Title: SYSTEM AND METHOD FOR INTERFEROMETER NON-LINEARITY
COMPENSATION

RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is responsive to the Final Office Action mailed March 31, 2004.